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Bib Data Sheet

CONFIRMATION NO. 9715

SERIAL NUMBER 10/630,293	FILING DATE 07/30/2003 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. SOEI/0057
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** CONTINUING DATA *****

none

** FOREIGN APPLICATIONS *****

JAPAN P2002-223614 07/31/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 10/27/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <i>Fourson</i> Initials <i>GF</i>	JAPAN	8	19	2

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TITLE

Ion implantation method, SOI wafer manufacturing method and ion implantation system

FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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